

### Applications of Genetic Optimization at ALS & Electron Beam Diagnostics using Compton Scattering Technique

Changchun Sun

Advanced Light Source (ALS) Lawrence Berkeley National Laboratory



**CBP seminar, Feb. 24, 2012** 







## Outline of the Talk

- Multi-Objective Genetic Algorithms (MOGAs)
- Applications at ALS
  - Low emittance lattice design and optimization for ALS upgrades
  - Curved superconducting combined-function magnet design
  - Spreader design and optimization for NGLS
- Electron beam diagnostics using Compton scattering technique







- Genetic Algorithm (GA) has been around 40 years. It was invented by John Holland and presented in his book "Adaption in Natural and Artificial Systems" from 1975.
- GA is a method to generate optimum solutions using techniques inspired by natural evolution, such as inheritance, mutation, selection and crossover.
- It is very suitable to solve complex multi-objective, multivariable optimization problems. It can quickly scan a vast solution set with trade-offs among the objectives.
- GAs have been widely used in many fields. However, it was only introduced to accelerator community several years ago, and quickly attracts a lot of interest.



ALS

### Flowchart of GA



A Pseudo code:

- 1: Randomly generate the first generation
- 2: Evaluate the first generation
- 3: Sort the first generation

4: Repeat

- 5: select parent to generate child (cross over)
- 6: mutate child
- 7: evaluate child
- 8: merge the parent and child
- 9: sort the mixed population
- 10: select the first half of the mixed populations
- 11: Until reach maximum generation





**Advanced Light Source** 





Office of Science

- For some optimization problems, usually, a large number of populations and generations are needed, and evaluation of objectives are often very time consuming.
- Cluster-based Master-Salve computing strategy
  - Master CPU performs genetic operations, such as cross over, mutation and selection, and distributes tasks to slave processors.
  - Slave CPUs evaluate the objective of problem and send the results back to master.
- Each slave performs their tasks independently, and there are no communication between them.

ALS

### **Code Parallelization**



- At ALS, we have developed a flexible and reliable Genetic Optimization tool using our own cluster (328 CPUs).
- We have successfully applied this optimization tool to different project.





Advanced Light Source



## Outline of the Talk

- Multi-Objective Genetic Algorithms (MOGA)
- Applications at ALS
  - Low emittance lattice design and optimization for ALS upgrade
  - Curved superconducting combined-function magnet design
  - Spreader design and optimization for NGLS
- Electron beam diagnostics using Compton scattering technique







ALS Upgrade

Office of Science

- The ALS is one of the earliest 3rd generation light sources, commissioned in 1993.
- The project of the low emittance upgrade began in 2009. After the upgrade finish, the brightness will be increased by 3 factors.



- The baseline upgrade lattice has a large-beta and dispersion function at the center of straight, and it doesn't provide ultimate insertion device brightness.
- Challenges for ultimate low beta lattice:
  - 1. Small dynamic aperture ----> need to be optimized
  - 2. Not compatible with traditional injection---> high and low beta lattice

**Advanced Light Source** 



# **Dynamic Aperture Optimization**

- Genetic algorithm is used to optimize the dynamic aperture of the low-beta lattice
- 6 parameters: (2 chromatic + 4 harmonic sextupoles)



The chromatic sextupole strength are given by chromaticities fitting

- Objectives:
  - Dynamic aperture area, which is commonly used or
  - → Total diffusion rates, newly proposed.







**Objectives** 

- Dynamic aperture area [M. Borland, Elegant V 23.1]
  - 21 line, and 11 steps for each line
  - → 4 interval splitting to refine the boundary
  - → 512 turns
  - Boundary is clipped to avoid the island
- Total diffusion rate [C. Steier and W. Wan, IPAC 2010]
  - Frequency Map Analysis
  - → 21 by 21 non-uniform grid search
  - → 512 turns for each grid.
  - Diffusion rate is calculated according to

$$d = \log\left(\frac{\sqrt{(v_{x,1} - v_{x,2})^2 + (v_{y,1} - v_{y,2})^2}}{N}\right)$$

- Diffusion rate is assigned to -3 for lost particle
- Boundary is clipped to avoid the island









### **Objectives at Different Generation**

#### The lattice errors: 0.03% quad field gradient and 0.05% coupling.





ALS

Changchun Sun , CBP seminar, Feb. 24, 2012

Office of Science



ALS Upgrade

- The ALS is one of the earliest 3rd generation light sources, commissioned in 1993.
- The project of ALS low emittance upgrade began in 2009. After the upgrade finish, the brightness will be increased by 3 factors.



- The baseline upgrade lattice has a large-beta and dispersion function at the center of straight, and it doesn't provide ultimate insertion device brightness.
- Challenges for ultimate low beta lattice:
  - 1. Small Dynamic aperture ----> need to be optimized

2. Not compatible with traditional injection---> high and low beta lattice

**Advanced Light Source** 





# ALS Two Options for High-Low Beta Lattice



Genetic Algorithm (GA) is used to design these high-low beta lattices







# ALS 6 Superperiods High-Low Beta Lattice



- 5 parameters: QF, QD, QFA, QF1, QD1
- 7 constraints: stability, positive partition number, maximum beta and dispersion functions
- **3 objectives:**  $|\beta_L 1|$ ,  $|\beta_H 10|$  and  $\varepsilon_x$



### 3 Superperiods L-H-H-L Beta Lattice



- 11 parameters: QFA, QD11, QF11, QF21, QD21, QD22, QF22, QF31, QD31, QFA1, QDA
- 7 constraints: stability, positive partition number, maximum beta and dispersion functions
- **3 objectives:**  $|\beta_L 1|$ ,  $|\beta_H 10|$  and  $\varepsilon_x$

ALS





## Outline of the Talk

- Multi-Objective Genetic Algorithms (MOGA)
- Applications at ALS
  - Low emittance lattice design and optimization for ALS upgrade
  - Curved superconducting combined-function magnet design
  - Spreader design and optimization for NGLS
- Electron beam diagnostics using Compton scattering technique





**Advanced Light Source** 



## Ion Beam Therapy Gantry





HIT 90 degree bend weigh 90 tons, 65% of total gantry weight

### The final 90 degree bend drives the size and cost!!!

**Advanced Light Source** 







## **Curved Superconducting Magnet**

# To reduce the size of the gantry, a double helix curved superconducting magnet is proposed.

S. Caspi



A straight double helix magnet

- → Two layer helical wire wound on a cylinder
- Solenoid magnet component are canceled
- Transverse field are doubled

**Advanced Light Source** 







## Magnetic Fields Requirements

Scanning requirements:

- 1. point-to-parallel scanning
- 2. Minimize beam size distortion

The magnetic field with dipole, quad and sextupole components is needed.





### **Challenges:**

How to wind the wire on the torus to generate the required the multi-pole field components?

**Advanced Light Source** 









### **Frequency Map**



The optimization using diffusion leads to an excellent nonlinear dynamic performance!

**Advanced Light Source** 





# Parameterizing Winding on Torus

- •A torus is generated by revolving a circle in 3D space about z-axis
- •Coordinates on torus:

ALS

 $x = (R_0 + R\cos\theta)\cos\phi$  $y = (R_0 + R\cos\theta)\sin\phi$  $z = R\sin\theta$ 



•Relation between  $\phi$  and  $\theta$ ,  $\phi = f(\theta)$ , determine the winding path:





Office of Science

**Advanced Light Source** 





### •Current path on torus

 $x = (R_0 + R\cos\theta)\cos\phi \quad y = (R_0 + R\cos\theta)\sin\phi \quad z = R\sin\theta$  $\phi = \theta/n + a_0\sin\theta + a_1\sin2\theta + a_2\sin3\theta$ 

•Magnetic fields are calculated using Biot-savart law





•Genetic solver:

- → 5 parameters: I, n, ao, a1,a2
- → 3 constraints: abs(Ci'-Ci)<0.05, i = 0,1,2
- → 3 objectives: less I, small n and abs(a<sub>0</sub>)+abs(a<sub>1</sub>)+abs(a<sub>2</sub>)

	С0	C1	C2	С3
"Ideal"	5.0000	-2.26	1.30	0

Office of Science



### **Optimal Solution Front**

Office of Science



Trade-off between current I, winding turns n, and coefficient ai:

- Less current, but more winding turns
- small ai, but more current and winding turns

**Advanced Light Source** 



# Winding Solution

I = 18 kA, n =216 turns,  $a_0$  = 0.168,  $a_1$ = -5.74e-03,  $a_2$ = 2.345e-04 inner pitch: 8.5 mm, outer: 10 mm





AUVANUEU LIYIIL OUUTUE





## Magnetic fields

0.16

0.14

0.12

1.5

L (m)

**C2** 

1.30

**C3** 

0

0.2

0.18

**C1** 

-2.26





#### **Advanced Light Source**

Changchun Sun , CBP seminar, Feb. 24, 2012



2

2.5





### Scanned Beam Spots at Patient







**Advanced Light Source** 



## Outline of the Talk

- Multi-Objective Genetic Algorithms (MOGA)
- Applications at ALS
  - Low emittance lattice design and optimization for ALS upgrade
  - Curved superconducting combined-function magnet design
  - Spreader design and optimization for NGLS
- Electron beam diagnostics using Compton scattering technique







### **NGLS Beam Spreader**







**Advanced Light Source** 



# CD0 Design

U.S. DEPARTMENT OF

Office of Science

.....

BERKELEY L

ALS



**Advanced Light Source** 



# **Optimization of CD0 Design**

•Optimization of the spreader is a multi-objective and multi-variable problem.

•Genetic Algorithm (GA) is well suitable to this task.

•The two achromats are optimized separately, and quad straight is used for the matching.

#### **Objectives:**

• Achromat: R16=R26=R36=R46=0

Evaluated using Differential Algebra (DA)

- Isochronous: R56=0 J
  Dispersion free at the Quad straight: eta=etap=0
- Length of the arc

#### Constraints:

- Maximal beta function < 70 m and dispersion function < 50 cm</li>
   Variables:
- Quad strength and drift length.
- 14 variables for the first achromat and 9 variable for the second achromat







ENERGY

Office of Science

ALS

.....

BERKELEY L





The new design (CD0v2) has the same performance to the original design in terms of CSR effects, magnet tolerance and high order chromatic effects.

**Advanced Light Source** 







#### 192 x12.5 m<sup>2</sup> ----> 147 x 6.8 m<sup>2</sup>







**Advanced Light Source** 



## Outline of the Talk

- Multi-Objective Genetic Algorithms (MOGAs)
- Applications at ALS
  - Low emittance lattice design and optimization for ALS upgrades
  - Curved superconducting combined-function magnet design
  - Spreader design and optimization for NGLS
- Electron beam diagnostics using Compton scattering technique





ALS

### Scattered Photon Energy





Head-on collision,

 $E_{\gamma} \approx \frac{4\gamma^2 E_p}{1 + \gamma^2 \theta_f^2 + 4\gamma^2 E_p / E_e}$ 

Backscattering,  $\theta_f$ 

$$\theta_f = 0$$

$$E_{\gamma}^{max} = \frac{4\gamma^2 E_p}{1 + 4\gamma^2 E_p / E_e}$$

$$E_g^{max} \approx 4\gamma^2 E_p$$

**Advanced Light Source** 

Changchun Sun, CBP seminar, Feb. 24, 2012



ENERGY

Office of Science



collimator

### Energy Spectrum of Scattered Photon Beam

For unpolarized/circularly polarized photons scattering with unpolarized electrons, the gamma-beam energy spectrum is given by



**Advanced Light Source** 

ALS

Changchun Sun, CBP seminar, Feb. 24, 2012

Office of Science

ALS

### **Beam-Beam Scattering**





Advanced Light Source





Office of Science

• Assuming Gaussian electron and laser beam:

$$\begin{split} f_e(x,y,z,x',y',p,t) &= \frac{1}{(2\pi)^3 \varepsilon_x \varepsilon_y \sigma_p \sigma_l} \exp\left[-\frac{\gamma_x x^2 + 2\alpha_x x x' + \beta_x x'^2}{2\varepsilon_x} \right. \\ &\left. -\frac{\gamma_y y^2 + 2\alpha_y y y' + \beta_y y'^2}{2\varepsilon_y} - \frac{(p-p_0)^2}{2\sigma_p^2} - \frac{(z-ct)^2}{2\sigma_z^2}\right], \\ f_p(x_l,y_l,z_l,k,t) &= \frac{1}{4\pi^2 \sigma_z \sigma_k \sigma_w^2} \exp\left[-\frac{x_l^2 + y_l^2}{2\sigma_w^2} - \frac{(z_l+ct)^2}{2\sigma_l^2} - \frac{(k-k_0)^2}{2\sigma_k^2}\right], \end{split}$$

• Neglecting the vertical emittance of the electron beam and the energy spread of the laser energy beam, we can obtain:

$$\frac{dN(E_g, x_d, y_d)}{dE_g dx_d dy_d} \simeq \frac{r_e^2 L^2 N_e N_p}{2\pi^2 \hbar c \beta_0 \sqrt{\zeta_x} \sigma_\gamma \sigma_{\theta x}} \int_{-\theta_{xmax}}^{\theta_{xmax}} \frac{\gamma}{1 + 2\gamma E_p / mc^2} \left\{ \frac{1}{4} \left[ \frac{4\gamma^2 E_p}{E_g (1 + \gamma^2 \theta_f^2)} + \frac{E_g (1 + \gamma^2 \theta_f^2)}{4\gamma^2 E_p} \right] - \frac{\gamma^2 \theta_f^2}{(1 + \gamma^2 \theta_f^2)^2} \right\} \times \exp \left[ -\frac{(\theta_x - x_d / L)^2}{2\sigma_{\theta_x}^2} - \frac{(\gamma - \gamma_0)^2}{2\sigma_\gamma^2} \right] d\theta_x,$$
(1)

#### **Advanced Light Source**





500 MeV electron beam scattering with 800 nm laser beam, and the radius of the collimation aperture is 16mm

ENERG

Office of Science

Both low and high energy edges are smeared due to the electron beam energy spread

**Advanced Light Source** 

ALS



### Effect of Electron Beam Emittance



The electron beam emittance has no impact on the high energy edge of the spectrum if the collimation aperture is large enough.

**Advanced Light Source** 







## HIGS Facility at Duke University

### HIGS: High Intensity Gamma-ray Source







#### **Advanced Light Source**

### **Energy and Energy Spread Measurement**



#### **Advanced Light Source**

ALS





# Apply Compton Scattering to NGLS?

• To measure electron beam energy at the end of the Linac, a long wavelength ( $\lambda = 10.6$  micro, Ep = 0.12eV) CO2 laser is needed.

$$E_g^{max} \approx 4\gamma^2 E_p$$

 $Ee = 2.4 \text{ GeV}, \gamma = 4696$ 

Eg = 10.3 MeV

→ Can be measured using HPGe detector

• The scatted photon flux is given by  $\frac{dN_{tot}}{dt} = N$ 

$$\frac{d_{tot}}{t} = N_e N_p \mathcal{L}_{sc} \overline{\sigma_{tot}} f_0$$

Office of Science

 $\mathcal{L}_{sc} = \frac{1}{2\pi\sqrt{\frac{\lambda\beta_0}{4\pi} + \beta_x\varepsilon_x}\sqrt{\frac{\lambda\beta_0}{4\pi} + \beta_y\varepsilon_y}} = 2e5 \text{ m}^2 = 6.65e-29 \text{ m}^2$ 

flux = 4.2e9 Q(nC) P(kW), for Q = 0.3 nC, P = 1kW

flux = 1.3 e9/sec  $\longrightarrow$  High enough

**Advanced Light Source** 



**Advanced Light Source** 

# **Conclusions**

I have been involved in different projects at ALS including low emittance lattice design, dynamic aperture optimization and charged particle optics design.

I also experienced with diagnostics of electron beam using different technique such as Compton scattering and Touchek Life time techniques.









### Thanks!





**Advanced Light Source** 



# **Backup slides**

**Advanced Light Source** 







• However, the ultimate upgrade lattice has small dynamic aperture, and is not compatible with traditional injection scheme due to a small beta at the straight. Optimization problems:

### 1. Dynamic aperture optimization

### 2. Alternating high and low beta lattice design

Advanced Light Source

Changchun Sun , CBP seminar, Feb. 24, 2012



8

Ultimate upgrade (small-beta)

6

10

12

14



16

### ALS Simultaneous Linear and Nonlinear Optimization



A trade-off between the dynamics and emittance is found.

**Advanced Light Source** 



### Optimize CD0v1 designed





- Keep the straight FODO lattice----10.8 meter per cell
- Keep the achromat structure ----- minimize the CSR effect
- Keep the first seven magnets' location and strength ---- the same space lim
- Keep all the bending magnet strength ----- 30 deg total bending angle
- Vary the quad strength and drifts downstream of the first quad in the arc
- Optimize using Multi-objective Genetic Algorithm (MOGA)

Advanced Light Source



Office of Science









Fig. 3. Layout of the gantry with the minimum number of quadrupoles: Q1-Q6 = quadrupoles,  $BM/45 = 45^{\circ}$  bending magnet,  $BM/90 = 90^{\circ}$  bending magnet, Sh = horizontal scanner, Sv = vertical scanner,  $IR = input pole face rotation (30^{\circ})$ ,  $ER = exit pole face rotation (21^{\circ})$ .





**Advanced Light Source** 

# **ALS** Coupled Spatial and Energy Distribution



- 800 nm photon scattering with MeV electron, and the observa plane is 60 meters downstrean from the collision point.
- High energy gamma photon as peaked around the center.
- Low energy gamma photon ar distributed away from the cent

#### **Advanced Light Source**





# ALS Spectrum High Energy Edge

### • Simple model [1]

$$\begin{split} f(E_{\gamma}, a1, \cdots, a_{5}) &= \int_{0}^{\infty} h(E_{\gamma}, E_{\gamma}^{H}) g(E_{\gamma}^{H}) dE_{\gamma}^{H} + a_{5} \\ &\approx \quad \frac{a_{3}}{\sqrt{2\pi}a_{2}} \int_{E_{\gamma}}^{\infty} \left[ 1 + a_{4}(E_{\gamma} - E_{\gamma}^{H}) \right] \times \exp\left(-\frac{(E_{\gamma}^{H} - a_{1})^{2}}{2a_{2}^{2}}\right) dE_{\gamma}^{H} + a_{5} \\ &= \quad a_{3} \left\{ \frac{1}{2} \left[ 1 + a_{4}(E_{\gamma} - a_{1}) \right] \times erfc\left(\frac{E_{\gamma} - a_{1}}{\sqrt{2}a_{2}}\right) - \frac{a_{2}a_{4}}{\sqrt{2\pi}} \times \exp\left(-\frac{(E_{\gamma} - a_{1})^{2}}{2a_{2}^{2}}\right) \right\} + a_{5} \end{split}$$

[1] R. Klein, T. Mayer, P. Kuske, R. Thornagel, and G. Ulm. Nucl. Instr. and Meth., A384:293–298, 1997.

Gamma-beam collimation and electron beam emittance effects are neglected.

• Comprehensive model

$$\frac{dN_{\gamma}}{dE_{\gamma}} \approx \frac{r_e^2 L^2 N_e N_p}{2\pi^2 \hbar c \beta_0 \sqrt{\zeta_x} \sigma_{\gamma} \sigma_{\theta x}} \int_{-y_o}^{y_o} \int_{-x_o}^{x_o} \int_{-\theta_{xmax}}^{\theta_{xmax}} \left(\frac{\bar{\gamma}}{1+2\bar{\gamma}a}\right) \times \left\{\frac{1}{4} \left[\frac{4\bar{\gamma}^2 E_p}{E_{\gamma}(1+\bar{\gamma}^2\theta_f^2)} + \frac{E_{\gamma}(1+\bar{\gamma}^2\theta_f^2)}{4\bar{\gamma}^2 E_p}\right] - \frac{\bar{\gamma}^2 \theta_f^2}{(1+\bar{\gamma}^2\theta_f^2)^2}\right\} \times \exp\left(-\frac{(\theta_x - x_c/L)^2}{2\sigma_{\theta_{xx}}^2} - \frac{(\bar{\gamma} - \gamma_0)^2}{2\sigma_{\gamma}^2}\right) d\theta_x dx_c dy_c$$
Advanced Light Source Changebun Sun, CBP seminar, Eeb. 24, 2012

Office of Science

### **ALS** Energy and Energy Spread Measurements

The set energy of the electron beam is adjusted with an increment of 0.02 MeV. The relative increase is about  $4*10^{-5}$ .

 $461.06 \rightarrow 461.08 \rightarrow 416.10 \rightarrow 461.12 \rightarrow 461.14 \text{ MeV}$ 



**Advanced Light Source** 





## ALS Measured Energy vs Set Energy



**Advanced Light Source** 

Changchun Sun, CBP seminar, Feb. 24, 2012



ALS

### **ALS** Uncertainty of the Energy Measurement

TAB. 1 – Uncertainty of the electron beam energy measurement at the storage ring set-energy of 461.06 MeV.



### **ALS** Uncertainty of the Energy Measurement

TAB. 1 – Uncertainty of the electron beam energy measurement at the storage ring set-energy of 461.06 MeV.

Error types	Gamma beam			FEL		
	$\delta E_g ({\rm keV})$	$\delta E_e^i~({ m MeV})^1$	$\delta E_e^i/E_e~(\times 10^{-5})$	$\delta\lambda_{ph}~({ m nm})$	$\delta E_e^i  ({ m MeV})^2$	$\delta E_e^i/E_e$ (×10 <sup>-2</sup>
Statistical	0.087	0.0040	0.87	0.0018	0.00052	0.11
Systematic	0.188	0.0087	1.9	0.032	0.0092	2.0

• The overall uncertainty of the measurement is about few 10^-5.

• This accuracy is comparable to another technique, Resonant Spin Depolarization.



